

For Wide Range of Applications, from Daily Life to Advanced Science and Technologies such as IoT, structural monitoring and robotics

## High-Sensitivity Accelerometer

High-Sensitivity Accelerometer, which can detect ultra-low accelerations, is developed. Innovative device design combined with advanced microfabrication technology enables substantial noise reduction.

Application to mentoring  
finger tip micro-movement



### Features

POINT  
**1**  
Microfabrication

MEMS accelerometer <sup>\*1,2</sup> is manufactured by advanced microfabrication technology developed by NTT laboratory.

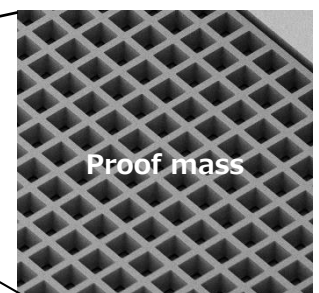
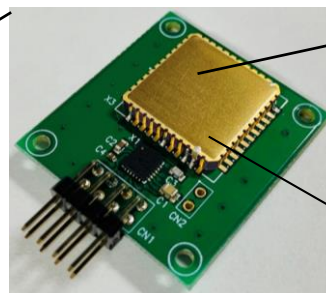
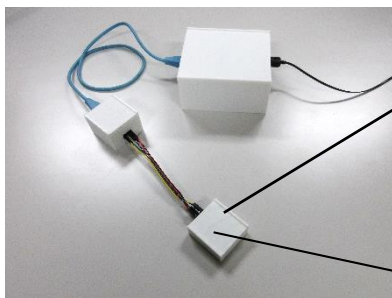
POINT  
**2**  
Noise Reduction

Optimal design of mechanical structure realized high sensitivity and low noise.

POINT  
**3**  
Flexible Customization

We will provide not only sensor chips, but also packages and modules on customers' requests.

Sensor Module



\*1. MEMS = Microelectromechanical Systems.

\*2. Japan Patent 5831905 (with Tokyo Institute of Technology) and Japan Patent 6044041 (with The University of Tokyo) are granted for parts of the technologies.

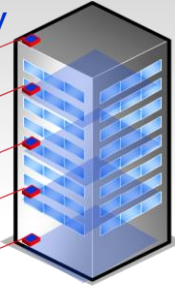
# Applications

Infrastructure/Machine health monitoring, trouble prediction/prevention, human body monitoring, etc.

## Building structural health monitoring

To observe long-term degradation (such as slanted, twisted)

High-sensitivity accelerometer



Data Collection and analysis

Visualization of the building health

## Piping health monitoring

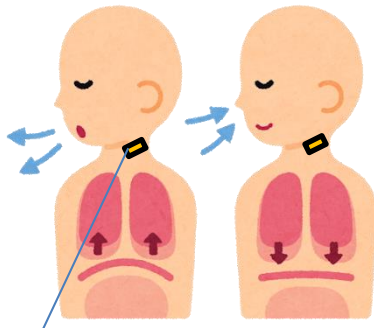
To observe long-term degradation such as clogged pipeline by observing the change of the natural vibration



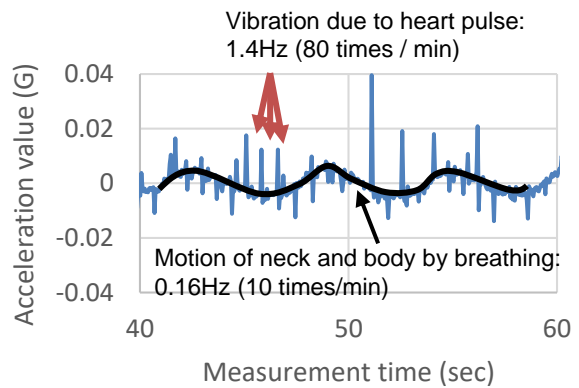
Data Collection and analysis

Prediction of the clogged pipeline and degradation

[Example : Heart rate and breathing motion]



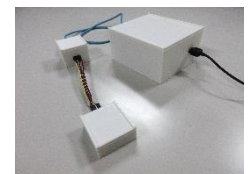
Accelerometer attached to carotid artery



# Specifications

Gravity range	+/- 2 G	+/- 4G
Axis	Z direction	
Module noise density (@BW = 220 Hz)	< 20 $\mu\text{G}/\sqrt{\text{Hz}}$	< 40 $\mu\text{G}/\sqrt{\text{Hz}}$
Band width (-3 dB)	~500 Hz	
Operating voltage	3.0 V – 3.6 V	
Supply current (@Sampling = 500Hz)	< 1 mA	
Interface	I <sup>2</sup> C, SPI	

Test module (wired)



Test module (BLE connection)



- Specifications may differ depending on the operating and environmental conditions.
- Features and specification may be subject to change without notice.
- Catalog descriptions: as of January, 2020

For more information

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[https://www.ntt-at.com/product/high-sensitivity\\_mems\\_accelerometer/](https://www.ntt-at.com/product/high-sensitivity_mems_accelerometer/)